



IPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79466

Takashi TONEGAWA

Appln. No.: 10/761,256

Group Art Unit: 2813

Confirmation No.: 2575

Examiner: Nguyen, Thanh T.

Filed: January 22, 2004

For: SEMICONDUCTOR DEVICE HAVING A Cu INTERCONNECTION AND METHOD
FOR MANUFACTURING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 18, 2005, in which the Examiner has required a restriction, Applicant responds by electing Group I, *i.e.*, claims 1-6, drawn to a semiconductor device. This election is made without prejudice to the filing of a divisional application directed to the non-elected claims.

Prompt and favorable action on the elected claims is now respectfully requested.

Respectfully submitted,

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Date: May 17, 2005